

UNITED STATES PATENT AND TRADEMARK OFFICE

BEFORE THE PATENT TRIAL AND APPEAL BOARD

MICRON TECHNOLOGY, INC.,
INTEL CORPORATION, GLOBALFOUNDRIES U.S., INC., and,
SAMSUNG ELECTRONICS COMPANY, LTD.,
Petitioners,

v.

DANIEL L. FLAMM,
Patent Owner.

PTAB Case No. IPR2017-00392¹
Patent No. 5,711,849

PETITIONERS' UPDATED EXHIBIT LIST

¹ Samsung Electronics Company, Ltd. was joined as a party to this proceeding via Motion for Joinder in IPR2017-01747.

Updated Exhibit List

Exhibit #	Description
1001	U.S. Patent No. 5,711,849 (“849 Patent”)
1002	File History for U.S. Patent No. 5,711,849
1003	Declaration of Dr. David Graves (“Graves Decl.”)
1004	<i>Curriculum Vitae</i> of Dr. David Graves
1005	Alkire et al., “Transient Behavior during Film Removal in Diffusion-Controlled Plasma Etching,” <i>J. Electrochem. Soc.: Solid-State Science and Technology</i> , March 1985, pp. 648-656 (“Alkire”)
1006	Kao et al., “Analysis of Nonuniformities in the Plasma Etching of Silicon with CF_4/O_2 ,” <i>J. Electrochem. Soc.</i> , Vol. 137 No. 3, March 1990, pp. 954-960 (“Kao”)
1007	Flamm et al., “The Reaction of Fluorine Atoms With Silicon,” <i>Journal of Applied Physics</i> , Vol. 52 No. 5, May 1981, pp. 3633-3639 (“Flamm”)
1008	K. F. Jensen, “Chemical Engineering in the Processing of Electronic and Optical Materials: A Discussion,” <i>Adv. Chem. Eng.</i> , 16(9): 395-412 (1991).
1009	K. F. Jensen and D. B. Graves, “Modeling and Analysis of Low Pressure CVD Reactors,” <i>J. Electrochem. Soc.</i> , 130(9): 1950-1957 (1983).
1010	D. W. Hess and K. F. Jensen, eds., <i>Microelectronics Processing</i> , 221(7-8): 362, 377-440 (May 5, 1989).
1011	K. F. Jensen, “Micro-Reaction Engineering: Applications of Reaction Engineering to Processing of Electronic and Photonic Materials,” <i>Chem. Eng. Sci.</i> , 42(5): 923-958 (1987).
1012	U.S. Patent No. 4,918,031 (“Flamm 031”)

1013	U.S. Patent No. 5,304,282 (“Flamm 282”)
1014	U.S. Patent No. 4,815,201 (“Harris 201”)
1015	U.S. Patent No. 5,453,157 (“Jeng 157”)
1016	Declaration of Mariellen F. Calter (“Calter Decl.”)
1017	Dennis M. Manos and Daniel L. Flamm, <i>Plasma Etching: An Introduction</i> , Academic Press, 1989.
1018	Steinfeld et al., <i>Chemical Kinetics and Dynamics</i> , Prentice Hall, Inc., 1989.
1019	Petition for <i>Inter Partes</i> Review, <i>Lam Research Corp. v. Daniel L. Flamm</i> , IPR2016-00466.
1020	S.M. Sze, <i>VLSI Technology</i> , McGraw-Hill Book Company, 1983.
1021	George B. Thomas, Jr., <i>Calculus and Analytic Geometry</i> , 4th Ed., Addison-Wesley Publishing Company, 1968.
1022	Affidavit of Jared Bobrow in Support of Petitioner’s Motion for Admission <i>Pro Hac Vice</i>
1023	Affidavit of Chad S. Campbell in Support of Petitioners’ Motion for <i>Pro Hac Vice</i> Admission Under 37 C.F.R. §42.1(c)
1024	Reply Declaration of Dr. David Graves (“Graves Reply Decl.”)
1025	Micron’s Hearing Demonstratives

Dated: March 5, 2018

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CERTIFICATE OF SERVICE

The undersigned hereby certifies that a true copy of the foregoing
UPDATED EXHIBIT LIST has been served in its entirety this 5th day of March,
2018, by electronic mail on Patent Owner via its attorneys of record:

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